

Attorney Docket No. 081468-0306524
Client Reference: P-0381.020-US

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Joeri LOF,
Antonius T. A. M. DERKSEN,
Christiaan A. HOOGEN DAM,
Aleksy KOLESNYCHENKO,
Erik R. LOOPSTRA,
Theodorus M. MODDERMAN,
Johannes C. H. MULKENS,
Roelof A. S. RITSEMA,
Klaus SIMON,
Joannes T. DE SMIT,
Alexander STRAAIJER,
Bob STREEFKERK, and
Helmar VAN SANTEN

Application No.:	Not Yet Assigned	Confirmation No:	Not Yet Assigned
Filed:	November 12, 2003	Group No.:	Not Yet Assigned
For:	Lithographic Apparatus and Device Manufacturing Method	Examiner	Not Yet Assigned

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: Joeri LOF
Citizenship: Dutch
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Second applicant: Antonius T. A. M. DERKSEN
Citizenship: Dutch
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Third applicant: Christiaan A. HOOGEN DAM
Citizenship: Dutch
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Fourth applicant: Aleksy KOLESNYCHENKO
Citizenship: Ukrain
Residence: Muzenplaats 110, Nijmegen 6525 JB, THE NETHERLANDS

Fifth applicant: Erik R. LOOPSTRA
Citizenship: Dutch
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Sixth applicant: Theodorus M. MODDERMAN
Citizenship: Dutch
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Seventh applicant: Johannes C. H. MULKENS
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Eighth applicant: Roelof A. S. RITSEMA
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Ninth applicant: Klaus SIMON
Citizenship: German
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Tenth applicant: Joannes T. DE SMIT
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Eleventh applicant: Alexander STRAAIJER
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Twelfth applicant: Bob STREEFKERK
Citizenship: Dutch
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Thirteenth applicant: Helmar VAN SANTEN
Citizenship: Dutch
Residence: Laagte Kadijk 17E, Amsterdam 1018 BB, THE NETHERLANDS

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: Lithographic Apparatus and Device Manufacturing Method

Docket number assigned to this application: 081468-0306524

Suggested Classification: Class:
 Subclass:
 Technology Center to which subject matter is assigned:

Total number of drawing sheets: 7

Type of application:

Utility

Application is to be published. Suggested drawing figure for publication: FIGURE 2

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Foreign priority information

Foreign priority is claimed for this application as follows:

Country: EUROPE
Application No.: 02257822.3
Filing Date: November 12, 2002

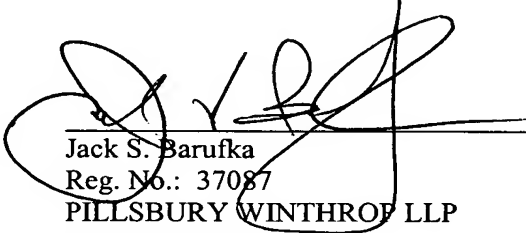
Country: EUROPE
Application No.: 03252955.4
Filing Date: May 13, 2003

6. Assignee information

The assignee(s) of this application is/are:

ASML Netherlands B.V.
De Run 1110, Veldhoven, 5503 LA, The Netherlands
Extent of interest of assignee in application: ENTIRE RIGHT, TITLE AND INTEREST

Date: November 12, 2003



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